



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Satya et al.

Attorney Docket No.: KLA1P016F

Application No.: 09/648,095

Examiner: OWENS, DOUGLAS W.

Filed: August 25, 2000

Group: 2811

Title: CHEMICAL MECHANICAL POLISHING  
TEST STRUCTURES AND METHODS FOR  
INSPECTION THE SAME

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on December 14, 2006 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: \_\_\_\_\_

Mrs. Mitchell Haynes

**SEPARATE LETTER TO EXAMINER  
REQUESTING DRAWING APPROVAL**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed are 35 sheets of Replacement Sheets for the above-identified patent application. If the Draftsman has any question concerning these drawings, he or she is respectfully requested to contact the undersigned.

Respectfully submitted,  
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